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Dated:

8-22-03

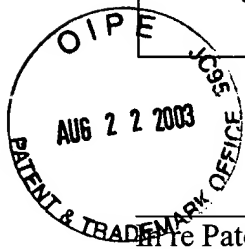
Signature:

(Anthony Soljanich)

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9/4/03

Docket No.: 299002052200

Client Ref.: F5-0136063/98R00651/US/END
(PATENT)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Entered
12-10-03

Re Patent Application of:

Koji TAKAHASHI and Hidenori KAWANISHI

Application No.: 09/786,977

Group Art Unit: 2822

Filed: June 7, 2001

Examiner: J. Brophy

For: METHOD FOR FORMING COMPOUND
SEMICONDUCTOR LAYER AND
COMPOUND SEMICONDUCTOR DEVICE

AFTER FINAL
EXPEDITED PROCEDURE

AMENDMENT

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the final Office Action dated June 23, 2003 (Paper No. 1460) for which a response is due on September 23, 2003. This response is filed within two months of the issuance of the final Office Action and therefore qualifies for expedited review. Reconsideration and allowance of the pending claims, as amended, in light of the remarks presented herein are respectfully requested.

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